Notice of References Cited Application/Control No. O9/543,016 Applicant(s)/Patent Under Reexamination VANDEGINSTE, GUDRUN Examiner Art Unit Paulos M. Natnael Applicant(s)/Patent Under Reexamination VANDEGINSTE, GUDRUN Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,237,417 A	08-1993	Hayashi et al.	348/569
	В	US-6,281,895 B1	08-2001	Jeong, Seok Hwa	345/810
	С	US-6,337,718 B1	01-2002	Kim, Pan-Jin	348/569
,	D	US-5,995,162 A	11-1999	Fujimori, Shin	348/569
	E	US-6,342,927 B1	01-2002	Kimoto et al.	348/569
	F	US-			
	G	US-			
	Н	US-			
	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.